High responsivity of GaN p-i-n photodiode by using low-temperature interlayer

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Gallium nitride p-i-n ultraviolet photodiodes with low-temperature (LT)-GaN interlayer have been fabricated. It was found that the dark current of photodiode with LT-GaN interlayer is as small as 143 pA at 5 V reverse bias. It was also found that the responsivity of the photodiode with LT-GaN interlayer can be enhanced at a small electric field (≈0.4 MV/cm) due to the carrier multiplication effect. The UV photocurrent gain of 13 and large ionization coefficient (α=3.1×10^5 cm^-1) were also observed in the detector with LT-GaN interlayer. Furthermore, we can achieve a large peak responsivity of 2.27 A/W from the photodiode with LT-GaN interlayer. © 2007 American Institute of Physics. [DOI: 10.1063/1.2800813]

Nitrile-based semiconductors have been commercialized on light-emitting diodes1 and laser diodes2 (LDs) due to their excellent optical and electrical properties. On the other hand, the devices based on nitrile semiconductors are also suitable as detectors for ultraviolet (UV) radiation detection because of their wide direct band gap, high breakdown fields, and high-temperature operation. GaN-based photodiodes have potential applications in chemical sensing, flame and heat detection, and missile detection.3,4 In the past few years, GaN p-i-n photodiodes have been fabricated in different types of structures.5–12 In this work, we present the properties of a p-i-n structure which inserts a low-temperature (LT)-GaN thin layer in intrinsic absorption layer. It is known that the LT-GaN layer as nucleation layer is necessary to grow high quality GaN epitaxial films.13 It is also known that LT-GaN interlayer can suppress threading dislocations extending to the subsequently grown high-temperature (HT)-GaN epitaxial layers.14,15 The LT-GaN cap layer can also be used to serve as the passivation layer of GaN Schottky diodes.16,17 We applied thin LT-GaN layer as an interlayer in the absorption layer of the GaN p-i-n structures. The electrical and optical properties of the fabricated photodiodes with and without LT-GaN interlayer will also be discussed.

The device structures of this work were all grown on c-plane (0 0 0 1) sapphire substrates by a low-pressure metalorganic chemical vapor deposition system. Trimethylgal-
evaporated onto the \( p \)-type GaN surface to serve as the \( p \) electrode. On the other hand, Cr–Pt–Au contact was deposited onto the exposed \( n \)-type GaN layer to serve as the \( n \) electrode. The wafers were then lapped down to 100 \( \mu \)m and fabricated to the size of 325 \( \times \) 325 \( \mu \)m\(^2\) chips. After these procedures, we used a HP-4156B semiconductor parameter analyzer to measure current-voltage (\( I-V \)) characteristics of the fabricated photodiodes. Spectral responsivity measurement was also performed by Jobin Yvon SPEX 1000M System with a xenon arc lamp light source. All the optical systems are calibrated by using an UV-enhanced silicon photodiode.

Figure 1 shows a measured photocurrent under xenon light source illumination at room temperature. It can be seen that the photocurrent increased largely after 20 V reverse bias at the sample with LT-GaN interlayer. The increase of photocurrent also shows an internal current gain in sample B. In contrast, the photocurrent of sample A was almost flat in the whole measurement range, as shown in Fig. 1. The inset of Fig. 1 shows the dark currents of the two fabricated photodiodes measured at room temperature. The dark currents of sample A at 5 and 40 V reverse biases are 15.7 pA and 36.6 nA, respectively, while the dark currents of sample B at 5 and 40 V reverse biases are 143 pA and 147 nA, respectively. The slight increase of dark current in sample B may be attributed to the leakage paths formed from LT-GaN interlayer. It can also be seen that the reverse breakdown voltage of both samples is more than 40 V. Thus, the current gain in sample B can not be attributed to avalanche multiplication effect.

Figure 2 shows the UV photoresponse to excitation with 360 nm light and dark current of sample B. The current gain was also shown in the right axis of Fig. 2 and determined by using the photocurrent at a bias of 1 V as the unity gain reference point. It was found that the current gain occurred at 20 V reverse bias and reached a value of 13 at 40 V reverse bias (limited by measurement equipment). It is known that the current gain can be obtained through the avalanche multiplication effect in avalanche photodiodes. The avalanche multiplication not only depends on the high electric field but also on the overall spatial distance. Electric fields around 3.5 and 2.8 MV/cm across the transition region with \( i \)-layer thicknesses 100 and 300 nm are necessary for GaN avalanche photodiodes to operate at avalanche mode.\(^{19,20}\) This large electric field in the transition region would provide an electron which was accelerated to high enough kinetic energy (\( >E_g \)) to cause an ionizing collision within the lattice. Such interaction would result in carrier multiplication. Comparing to these avalanche photodiodes, the thickness of absorption layer of sample B is larger than that of avalanche photodiode. The carrier multiplication would be achieved with a lower estimated electric field at around 0.4 MV/cm (with 40 V reverse bias across the 1000 nm \( i \) layer) by the \( p-i-n \) structure proposed in this work (sample B). It was also known that the crystal quality of LT-GaN layer is not as good as the quality of HT-GaN layer. Then, some defect related trap levels should exist within the band gap of LT-GaN interlayer. The bonding energy of defect-trapped carriers should be smaller than the energy of lattices bonding. Thus, less energy is needed to cause the carrier multiplication from these energy levels within the band gap of the LT-GaN interlayer. The electric field we need in sample B is much smaller than those in other reported GaN avalanche photodiodes.\(^{19,20}\) It is also found that the current gain increased smoothly, which means that no microplasma emissions are observed.\(^{19} \)

Figure 3 shows the ionization coefficient of sample B versus applied reverse bias. The ionization coefficient (\( \alpha \)) can be extracted from the following equation by the assumption that electron (\( \alpha_e \)) and hole (\( \alpha_h \)) ionizations are the same in GaN (\( \alpha_e=\alpha_h=\alpha \)).\(^{21}\)

\[
M = \frac{1}{1 - \int_0^L \alpha \, dx},
\]

where \( M \) is the multiplication gain, \( L \) is the length of multiplication region, and \( \alpha \) is the ionization coefficient. Since the...
carrier multiplication only happened in the photodiode with LT-GaN interlayer, we can assume that the multiplication region is exactly the LT-GaN interlayer, i.e., $L = 30$ nm. Thus, the ionization coefficient which can be calculated from the above equation is $3.1 \times 10^{7}$ cm$^{-1}$. This value of ionization coefficient is larger than those in other reported photodiodes by Carrano et al.\textsuperscript{22} ($\alpha = 9.6 \times 10^{6}$ cm$^{-1}$) and Limb et al.\textsuperscript{23} ($\alpha = 3.3 \times 10^{6}$ cm$^{-1}$). The larger ionization coefficient could be attributed to the large multiplication carrier generated from the defect-trapped levels in the LT-GaN interlayer. In Fig. 3, we also observed the soft ionization at a small reverse bias ($< 20$ V) and the saturation trend at high reverse bias. The soft ionization may be due to the trap-assisted tunneling mechanism by the defect-trapped levels in the LT-GaN interlayer.\textsuperscript{22} The saturation trend in ionization coefficient shows the multiplication carrier generated from the intermediate energy states, not from the valence band.\textsuperscript{23}

Figure 4 shows the responsivities of samples A and B, which are measured at 360 nm wavelength. A typical responsivity of a GaN $p-i-n$ photodiode varied with voltages was observed in sample A. The responsivity increased slightly with increasing applied voltage. The 360 nm wavelength responsivities of the sample A at 0 and 40 V reverse biases are 0.18 and 0.24 A/W, respectively. The slight decrease of responsivity in sample A at high reverse bias (> 35 V) could be attributed to the increasing high dark current. In contrast, the responsivity of sample B increased largely with increasing applied voltage because of the carrier multiplication effect. The 360 nm wavelength responsivities of sample B at 0 and 40 V reverse biases are 0.16 and 2.27 A/W, respectively. In Fig. 4, it was also found that the peak responsivity (360 nm) of sample B was smaller than that of sample A at a reverse bias of less than 25 V. This may be due to that the photogenerated carriers were compensated by the defect levels of LT-GaN interlayer in sample B. On the other hand, the responsivity of sample B was much larger than that of sample A when the applied bias was higher than 25 V reverse bias. This could be attributed to the carrier multiplication effect caused by the same defect levels of LT-GaN interlayer in the sample B. The peak responsivity of sample B was 9.5 times larger than that of the sample A at 40 V reverse bias.

In summary, nitride-based $p-i-n$ UV photodiodes with LT-GaN interlayer have been fabricated. It was found that the dark current of photodiode with LT-GaN interlayer is as small as 143 pA at 5 V reverse bias. It was also found that the responsivity of the photodiode with LT-GaN interlayer can be enhanced at a small electric field (~0.4 MV/cm) due to the carrier multiplication effect. The UV photocurrent gain of 13 and large ionization coefficient ($\alpha = 3.1 \times 10^{5}$ cm$^{-1}$) were also observed in the detector with LT-GaN interlayer. Furthermore, we can achieve a large peak responsitivity of 2.27 A/W from the photodiode with LT-GaN interlayer. This value of responsivity is 9.5 times larger than the responsivity of the conventional $p-i-n$ GaN photodiode.

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